

Form PTO-1449 (Modified)	Atty Docket No. H1540	Serial No. 10/755,658
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	Applicant: LaFontaine, et al.	
	Filing Date 1/12/04	Group <u>2851</u> Not yet assigned



U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Sub-class	Filing Date if Appropriate
HW	6,353,271	3/2002	Williams			

OTHER ART

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.
HW	Briefing: EUV Mask Chucking Standards [online]. Retrieved from the Internet: <URL: http://www.sematech.org/public/resources/litho/euvl/euvlmask030702/1-Agenda.pdf >, EUVL, pages 1-29.
HW	Surface Flatness Measurements [online] [retrieved on July 9, 2003]. Retrieved from the Internet: <URL: http://www.phase-shift.com/interferometer-flatness.html >.
HW	Specifications Guide, 4810 Non-Contact Capacitance Gaging Instrument, Copyrighted 2002, ADE Technologies.
HW	Specifications Guide, Microsense II - 5810, Non-Contact Capacitance Gaging Module, Copyrighted 2002, ADE Technologies.

EXAMINER <u>H. Nguyen</u>	DATE CONSIDERED <u>2/1/2005</u>
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Information Disclosure Statement PTO-1449 (Modified)

The identification of any reference is not intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be antedated. The "prior art" status of any reference is a matter to be resolved during prosecution.

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